



PATENT
8017-1122

IN THE U. S. PATENT AND TRADEMARK OFFICE

In re application of

Noriaki ODA Conf. 2345
Application No. 10/761,204 Group 2826
Filed January 22, 2004 Examiner Alexander Williams

SEMICONDUCTOR DEVICE AND METHOD OF
FABRICATION SAME

AMENDMENT

MS AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450 August 30, 2005

Sir:

Responsive to the Official Action of June 30, 2005, for which the period for response has been extended one month, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.